

# MOD SILVER METALLIZATION: SCREEN PRINTING AND INK-JET PRINTING

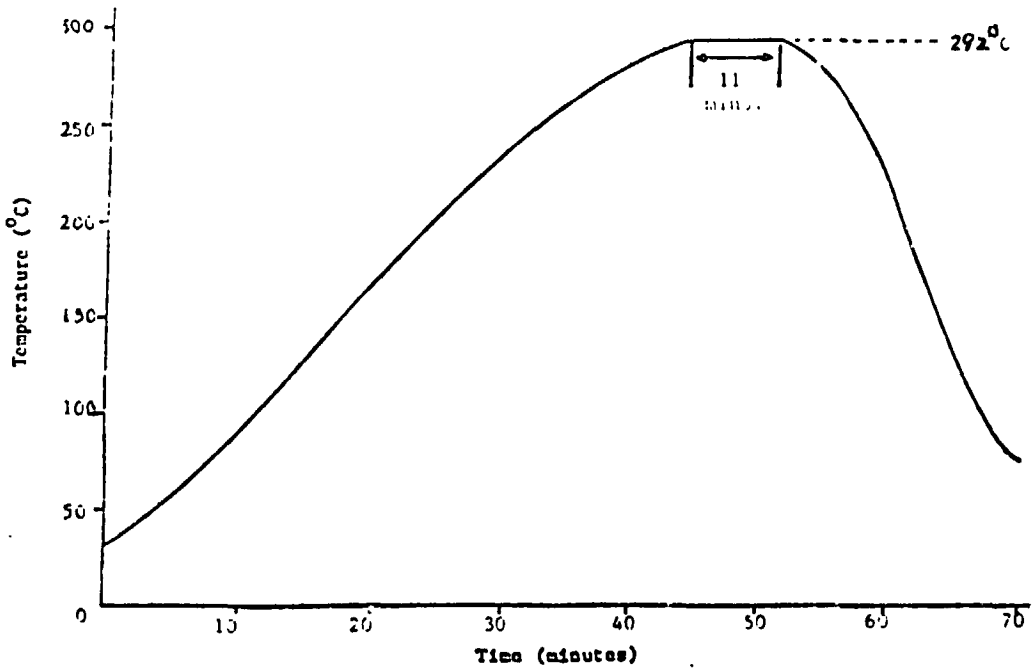
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## Experimental Variables

1. Ink Chemistry
2. Deposition Parameters
3. Time-Temperature Processing

### Time-Temperature Profile for Standard Firing Sequence No. 1



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# PROCESS DEVELOPMENT

## Ink Chemistry

1. Silver Compound  
Ag Neodecanoate
2. Adhesion Agent
3. Solder Leach Resistant Agent
4. Solvent(s)
  - a. Screen Printing
    - Low Boiling - Benzene
    - High Boiling - Neodecanoic  
Acid: Butyl Carbitol  
Acetate (2:1)
  - b. Ink Jet Printing
    - Low Boiling



## PROCESS DEVELOPMENT

Properties of Metallo-Organic Base Metal Oxide Binder Compounds and Those of Silver Inks Formulated with Them.

Binder Compound	T <sub>D</sub> (°C)	w/o Product	T <sub>D</sub> for 97/3 Ink (°C)	Comments
Bismuth 2-ethylhexanoate in benzene	340	14.4	310	Smooth ink decomposition with all but 1 w/o decomposed by 270°C.
Chromium (II) 2,4-pentanedionate solid	270 <sup>(a)</sup>	4.2	318	Definite 2-stage ink decomposition occurs at 232°C.
Nickel 2-ethylhexanoate in benzene	323	5.0	292	All but 3.6 w/o decomposed by 232°C. Possible 2-stage decompositing occurring.
Cobalt 2-ethylhexanoate in benzene	292	8.4	283	2-stage ink decomposition occurs at 243°C and 283°C, although its not as severe as in Ag/Cr ink.

(a) Except for 1 w/o, which decomposed by 365°C.

# PROCESS DEVELOPMENT

Fired Front Contact Properties of Inks with Four Different Compounds Added for Potential Adhesion Promotion.

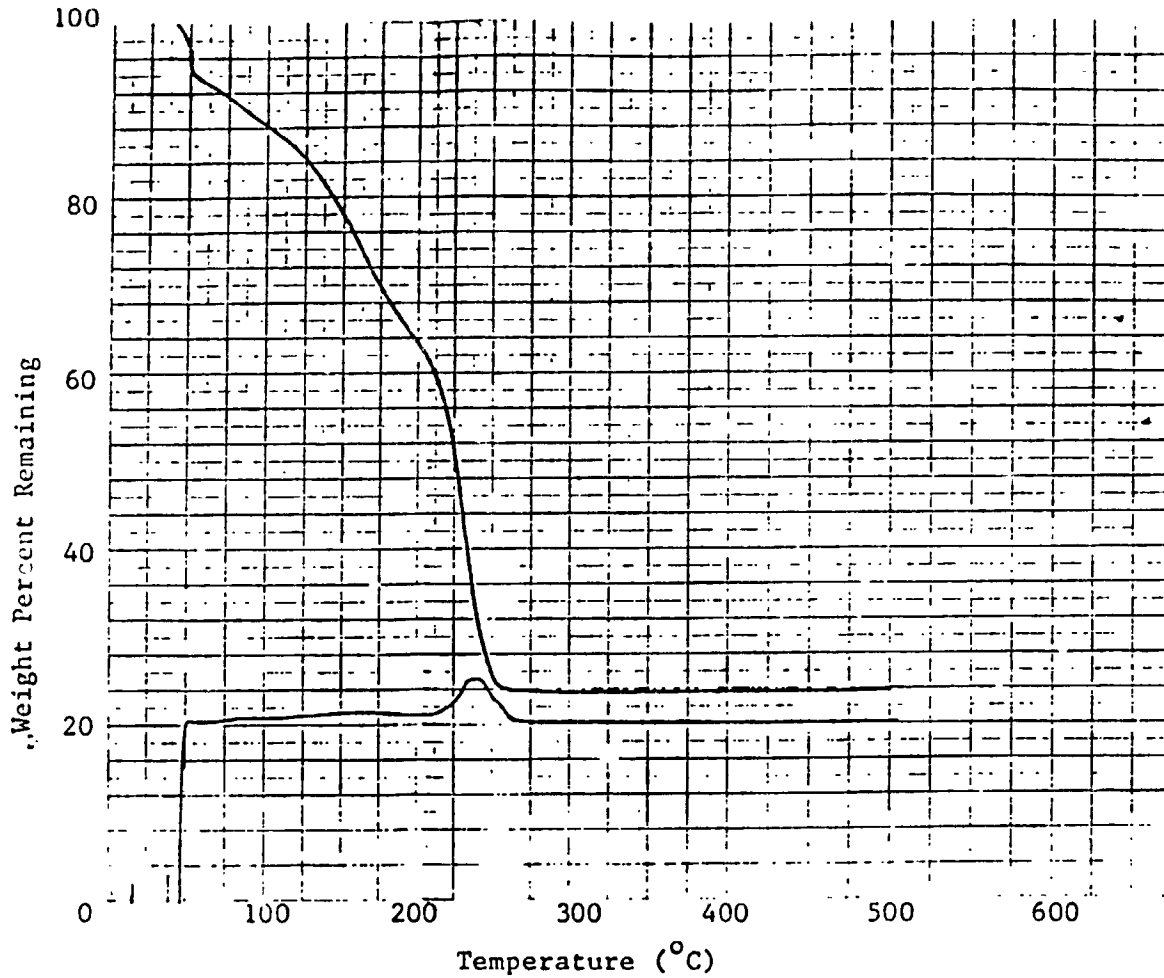
Ink	Fired Film Appearance	Line Defn.	Sheet Resistance ( $m\Omega/sq \pm \sigma$ )		Initial Adhesion	
			# of Films	Initial Value		Value After 60 sec. Spike at 800 °C
Ag/Bi (SPC3-3A)	silver with copperish tint	A	16	40.1 <sup>+</sup> <sub>-3.9</sub>	24.9 <sup>+</sup> <sub>-1.5</sub>	excellent
Ag/Cr	dark silver/grey	A/B	7	89.0 <sup>+</sup> <sub>-3.8</sub>	51.2	good to excellent
Ag/Ni	dark with purple tint	A	9	157.7 <sup>+</sup> <sub>-7.5</sub>	91.3	excellent
Ag/Co	dark with greenish yellow tint	A	9	>860	98.3	fair to good

# PROCESS DEVELOPMENT

## Firing Study Results for Bismuth Oxide Content Optimization

Ink <sup>(a)</sup> Chemistry	# of Layers	Line Defin.	Sheet Resist. (mΩ/sq)	Initial Adhesion
95% Ag 5% Bi	1	A	57.9	Excellent
95% Ag 5% Bi	2	A	32.3	One half of bus bar poor. Excellent elsewhere.
97% Ag 3% Bi	1	A	40.3	Excellent
97% Ag 3% Bi	2	A/B	24.6	Excellent, small piece of bus bar removed.
99% Ag 1% Bi	1	A/B	38.8	Excellent
99% Ag 1% Bi	2	B	21.1	One half of bus bar poor. Excellent elsewhere.

(a) Based on expected theoretical fired film composition which is not verified analytically.



Thermogram of ink SC-10 at 10°C/minute

Important Properties

Theor. Fired Film Composition: 99 wt.% Ag - 1 wt.% Bi

T<sub>D</sub>: 257°C

Inorganic Content: 23.6 wt. %



# PROCESS DEVELOPMENT

Fired Film Thickness Values and Resistivity Calculated Values.

Film I.D.	Average Film Thickness ( $\mu\text{m}$ )			Sheet Resist. ( $\mu\Omega/\text{sq}$ )	Resistivity ( $\mu\Omega\text{-cm}$ )
	Bus Bar	Finger	Overall Average		
1 Layer Pure Silver	1.08	0.62	$7.6 \times 10^{-5}$	$2.62 \times 10^4$	1.99
1 Layer 1 w/o Bi	0.75	0.53	$5.9 \times 10^{-5}$	$3.88 \times 10^4$	2.30
1 Layer 3 w/o Bi	1.21	0.58	$7.7 \times 10^{-5}$	$4.03 \times 10^4$	3.11

# PROCESS DEVELOPMENT

## Summary of the Effects of 60 Second Thermal Spiking.

Bismuth Content (wt. %)	Spiking Temp. (°C)	Initial Sheet Resist. (mΩ/sq)	Final Sheet Resist. (mΩ/sq)	Δ Sheet Resist. (mΩ/sq)	Adhesion Effects	Photovoltaic Response Improvement
5	600	57.8	27.1	30.7	Good before spiking. Excellent after spiking.	Slight Negative
5	700	61.0	26.9	34.1	Same as Above	Very Positive
5	750	59.2	27.1	32.1	Same as Above	Very Positive
5	800	53.6	25.7	27.9	Same as Above	Very Positive
3	600	41.4	27.5	13.9	Excellent Before & After Spiking.	None
3	700	39.6	26.0	13.6	Same as Above	Slight Negative
3	750	37.7	26.5	11.2	Same as Above	Positive
3	800	37.3	24.9	12.4	Same as Above	Positive
1	600	37.4	26.1	11.3	Excellent Before & After Spiking.	Slight Positive
1	700	37.8	24.2	13.6	Same as Above	Positive
1	750	38.0	27.9	10.1	Same as Above	Very Positive
1	800	36.4	28.6	7.8	Same as Above	Very Positive

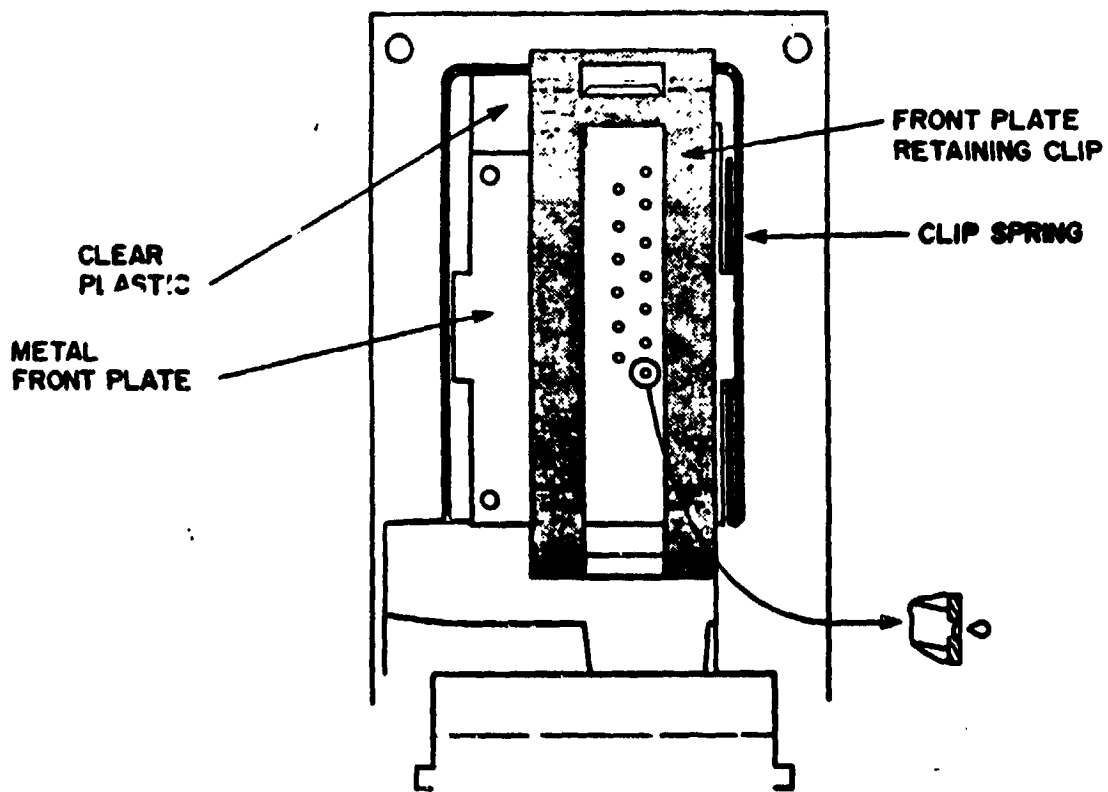


# PROCESS DEVELOPMENT

Photovoltaic Evaluation of MOD Silver (1 w/o Bi) Metallized Solar Cells  
Without AR Coating.

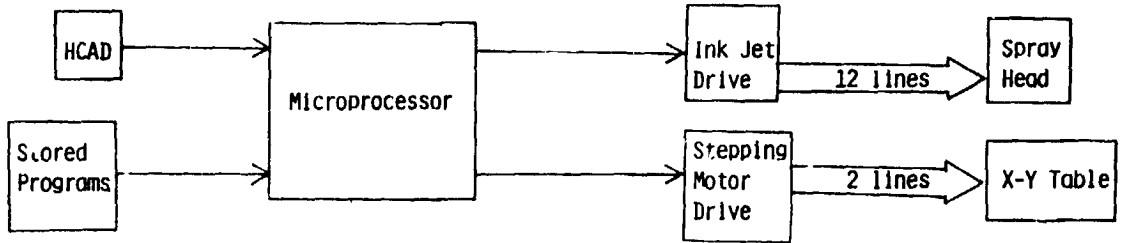
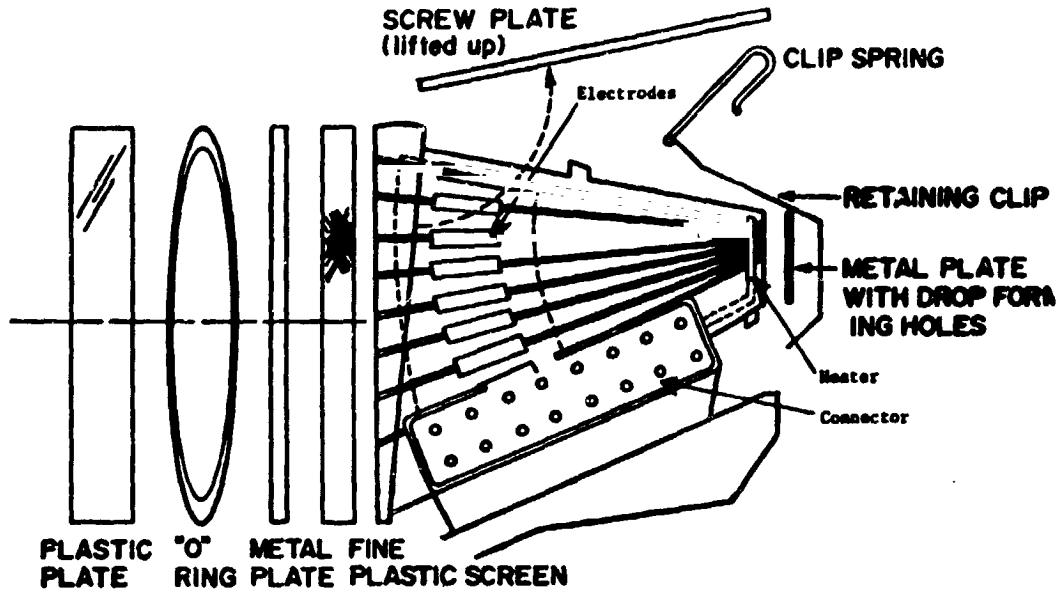
Cell Description	V <sub>OC</sub> (mV)	I <sub>SC</sub> (mA)	Efficiency (%)	Fill Factor	Series Resist. (ohms)	Shunt Resist. (ohms)	Sheet Resist. (mΩ/sq)
Single Layer MOD Silver	530.4	72.6	6.1	0.633	1.171	99.4	39
Two Layer MOD Silver	522.6	66.8	3.5	0.401	2.658	49.8	21

Nozzle Assembly (Front View)

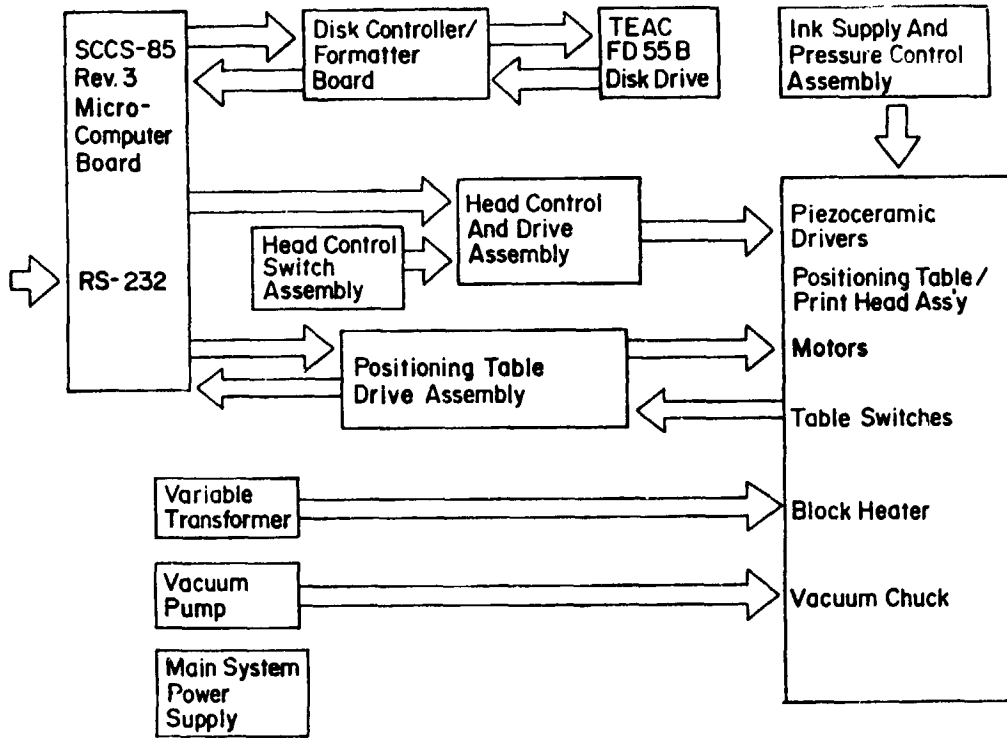


PROCESS DEVELOPMENT

Nozzle Assembly (Side View)



### Ink-Jet Printing System



### Ink Requirements

1. No Particulates
2. Low Viscosity
3. High Surface Tension
4. High Inorganic Content
5. Non Clogging
6. Stable

## Ink-Jet Printing Studies

### Ink Parameters

1. viscosity
2. surface tension
3. metal content
4. solvent vapor pressure

### Printer Parameters

1. pulse voltage
2. pulse frequency
3. ink pressure
4. nozzle diameter
5. nozzle-substrate separation

### Substrate Parameters

1. velocity
2. temperature

### Firing Parameters

1. heating rate
2. maximum temperature
3. time at maximum temperature

## Solvents Evaluated for Ink-Jet Printing

Solvent	B.P. (°C)	Comments
xylene	137	Poor line definition for thick prints.
toluene	111	Poor line definition for very thick prints
cyclohexane	80.7	Voids in prints
benzene	80	Good prints
hexane	69	Clogging
tetrahydrofuran	66	Clogging

## Theory

w - dry film width

t - dry film thickness

$$tw = C \left( \frac{f}{s} \right) v$$

C - constant for a given ink and printer

f - drop frequency

s - substrate speed

v - velocity of ink in nozzle

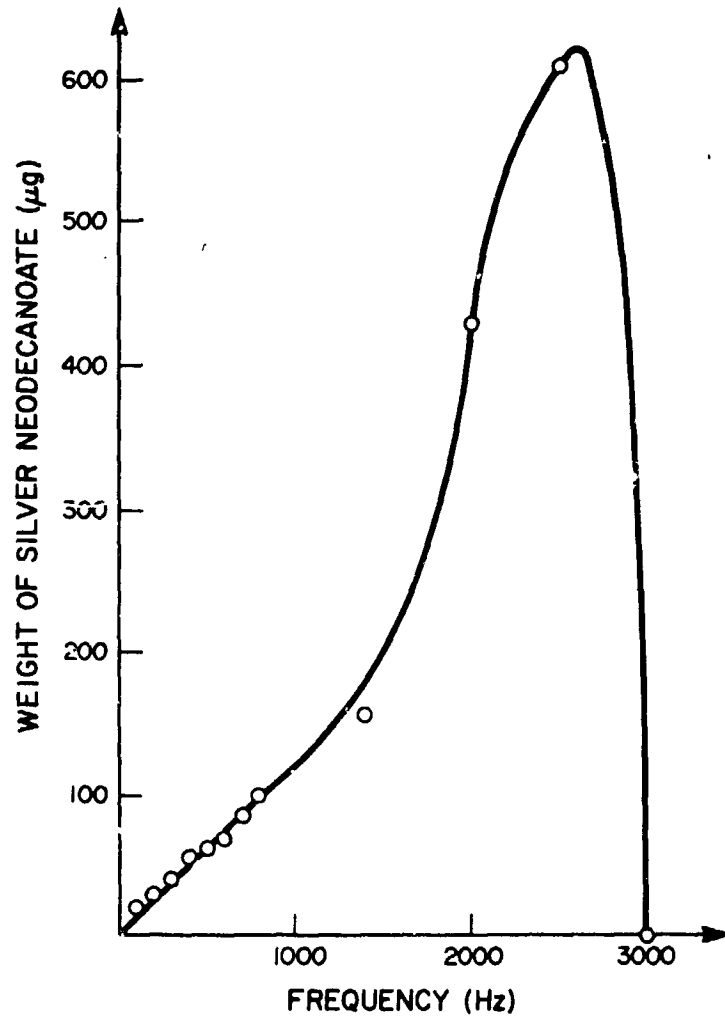
$v = v(n, \gamma, V)$  for a given printer

n - ink viscosity

$\gamma$  - ink surface tension

V - input voltage

## PROCESS DEVELOPMENT



### Summary

1. Screen printed MOD Ag films with low porosity and excellent adhesion can be formed on Si below 300°C.
2. The photovoltaic response is promising, but the contact resistance must be reduced.
3. Excellent line definition can be achieved with ink jet printed MOD inks.